

Form PTO-1449

US DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

*Complete if Known*

Application Number	10/673,384
Filing Date	September 26, 2003
First Named Inventor	Yukihisa TAKEUCHI
Art Unit	2879
Examiner Name	Joseph L. Williams
Confirmation No.	2569
Attorney Docket No.	789_116

Sheet 1 of 1

**U.S. PATENT DOCUMENTS**

Exam. Initial	Document Number	Date	Name	Our Docket No.	Class	Sub Class	Filing Date

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	Class	Sub Class	Translation	Abstract
/JW/	DC	01/71759	09/27/2001	WO				✓
/JW/	DD	1 278 227 A1	01/22/2003	EP				
/JW/	DE	2000-285797	10/13/2000	JP			JPO Machine Translation	✓
/JW/	DF	2000-306493	11/02/2000	JP			JPO Machine Translation	✓

**OTHER DOCUMENTS**

(Including Author, Title, Date, Pertinent Pages etc.)

/JW/	DG	Nakajima et al., "Generation of ballistic electrons in nanocrystalline porous silicon layers and its application to a solid-state planar luminescent device," Applied Physics Letters, Volume 81, Number 13, 23 September 2002, pp. 2472-2474.						
/JW/	DH	Nakajima et al., "A Solid-State Light-Emitting Device Based on Excitations of Ballistic Electrons Generated in Nanocrystalline Porous Polysilicon Films," Jpn. J. Appl. Phys. Vol. 41 (2002) pp. 2707-2709						

Examiner:	/Joseph Williams/ (11/25/2007)	Date Considered:	11/25/2007
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.